



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 25, 2026	
IGI Report Number	LG819607985
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.36 - 7.40 X 4.48 MM

GRADING RESULTS

Carat Weight	1.50 CARAT
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	EXCELLENT

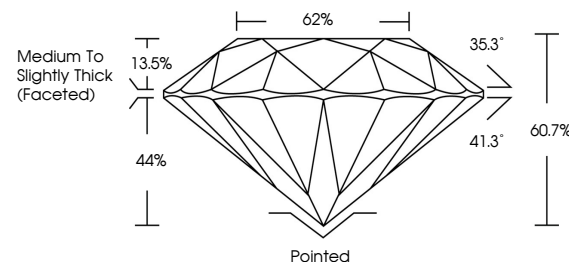
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG819607985

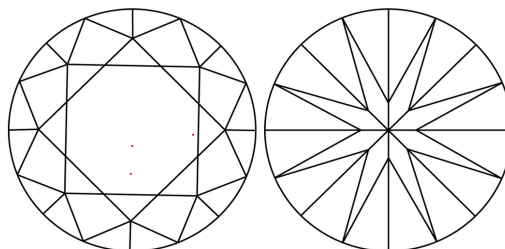
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG819607985
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

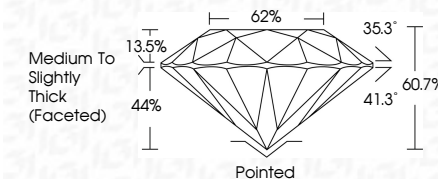
FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



July 25, 2026	
IGI Report Number	LG819607985
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.36 - 7.40 X 4.48 MM

GRADING RESULTS

Carat Weight	1.50 CARAT
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	EXCELLENT



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG819607985
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa	



© IGI 2020, International Gemological Institute

FD - 10 20

www.igi.org

THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES

July 25, 2026	Color Weight	Cutlet
GL Report No. G81907985	Color Grade	Polish
ROUND BRILLIANT	Clarity Grade	Symmetry
	Cut Grade	Fluorescence
	Depth	Inscriptions(s)
	Table	
	Girdle	
		Medium Thickness
		Appl

Comments: 1. Laboratory Grown Diamond
2. Assessed by Chemical Vapor Deposition (CVD) growth process.
3. Type Ila